S&H Form: (2/01)

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PATENT			Γ AND TRADEMARK OFFICE		1359.1040 FIRST NAMED INVENTOR			09/785,994		
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LIST OF	REFE	RENCES C	ITED BY A	PPLICANT	Takao MOHRI et al. FILING DATE GROUP ART UNIT					INIT .
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	AM	Sousa, Pedro et al., "Object Clustering in Persistent and Distributed Systems", pages 402-								
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Drawline through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.										

ATTACHMENT 1(e)

EXPLANATIONS OF RELEVANCY OF REFERENCES

ATTORNEY DOCKET NO.	APPLICATION NO.				
1359.1040	09/785,994				
FIRST NAMED INVENTOR					
Takao MOHRI et al.					
FILING DATE	GROUP ART UNIT				
February 16, 2001	2 152 2155				

Japanese Reference AG corresponds to U.S. Reference AA.

Japanese Reference AI corresponds to U.S. Reference AC.



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